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Bib Data Sheet

CONFIRMATION NO. 4889

SERIAL NUMBER 09/885,027	FILING DATE 06/21/2001 RULE	CLASS 257	GROUP ART UNIT 2815	ATTORNEY DOCKET NO. 036654.04
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APPLICANTS

Mitsutoshi Miyasaka, Nagano-ken, JAPAN;

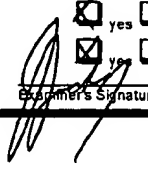

** CONTINUING DATA *****

This application is a CON of 09/373,982 08/16/1999 PAT 6,335,542
which is a DIV of 09/023,695 02/13/1998 PAT 6,017,779 *
which is a CON of 08/591,681 02/15/1996 PAT 5,858,819 *
~~(*) Data provided by applicant is not consistent with PTO records.~~

** FOREIGN APPLICATIONS *****

JAPAN 6-133374 06/15/1994
JAPAN 7-72144 03/29/1995

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 07/17/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 2	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature:  				

ADDRESS
25944
OLIFF & BERRIDGE, PLC
P.O. BOX 19928
ALEXANDRIA, VA
22320

TITLE
Fabrication method for a thin film semiconductor device, the thin film semiconductor device itself, liquid crystal display, and electronic device

FILING FEE RECEIVED 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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